Retraction

Retraction: Nebhen, J., et al. Constant Temperature Anemometer with Self-Calibration Closed Loop Circuit. *Appl. Sci.* 2020, 10, 3405**Applied Sciences Editorial Office**

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In the published paper [1], Figure 1 is identical to Figure 1a published in the journal *Applied Physics Letters* [2], Table 1 is similar to Table 1 published in the journal *Sensors and Actuators A: Physical* [3], and Figure 2 is identical to Figure 3a published in the journal *Applied Physics Letter* [2] and Figure 1b published in the journal *Experiments in Fluids* [4]. The text from the Introduction is identical to the contents published in the journal *Sensors and Actuators A: Physical* [3]. The text from Section 2 is similar to the contents published in the journal *Sensors and Actuators A: Physical* [3]. The authors provided explanations for the similarities that were not accepted by the journal editor. After thorough investigation, the journal has therefore made the decision to retract the paper [1]. The Editor-in-Chief and Editorial Office of the Applied Sciences have checked the case, and the Editor-in-Chief has approved the retraction.

The *Applied Sciences* Editorial Office apologize to the readers of *Applied Sciences* for any inconvenience caused. To ensure the addition of only high-quality scientific works to the field of scholarly communication, this paper [1] is retracted and shall be marked accordingly. MDPI is a member of the Committee on Publication Ethics (COPE) and takes very seriously the responsibility to enforce strict ethical policies and standards.

References

1. Nebhen, J.; Alnowaiser, K.; Mansouri, S. Constant Temperature Anemometer with Self-Calibration Closed Loop Circuit. *Appl. Sci.* **2020**, *10*, 3405. [\[CrossRef\]](#)
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3. Ghouila-Houri, C.; Gallas, Q.; Garnier, E.; Merlen, A.; Viard, R.; Talbi, A.; Pernod, P. High temperature gradient calorimetric wall shear stress micro-sensor for flow separation detection. *Sens. Actuators A Phys.* **2017**, *266*, 232–241. [\[CrossRef\]](#)
4. Ghouila-Houri, C.; Talbi, A.; Viard, R.; Gallas, Q.; Garnier, E.; Merlen, A.; Pernod, P. Unsteady flows measurements using a calorimetric wall shear stress micro-sensor. *Exp. Fluids* **2019**, *60*, 67. [\[CrossRef\]](#)

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